

VANTAGE QUICKSTART 300mm RADIANCE CHAMBER PROCESS OVERVIEW

Who should attend?

This course is designed for those individuals in the semiconductor industry who require a general understanding of the process run by the Vantage Quickstart 300mm Radiance Chamber.

Course Benefits

Increase knowledge of the RTP process and understand the process fundamentals of the Vantage RTP Radiance Chamber.

Course Objectives

- Describe the overall chip manufacturing process.
- Describe the RTP process and its purpose.
- Identify the types of hardware used in the RTP process.
- Describe and identify the major process recipes used in the Radiance chamber.
- Describe the components and steps that make up an RTP process recipe.

Course Modules

1. *Chip manufacturing process*
2. *RTP process*
3. *Major process recipes*

Registration Information

Prerequisites: *None*

Course Length: *0.5 Hours*

Course Type: *Web-based Training*

Course Number: *TRNWEB-130*

To enroll or for more information on our products and services, please call our registrar at one of the numbers below or go to www.appliedtraining.com.

- 1-800-468-8888, option 4 (United States)
- 1-512-272-0027 (International)

Computer System Requirements:

Attending this course requires a Windows 98, NT, 2000 or XP computer using Internet Explorer 5.5 or higher. 128MB RAM or higher and high-speed Internet access is also highly recommended.